

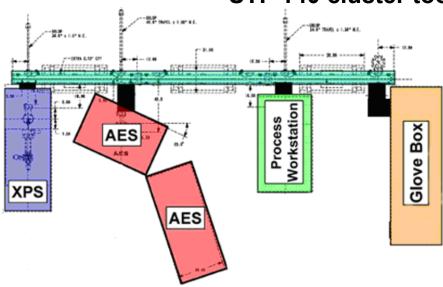
## A Liquid-Phase Quartz Crystal Microbalance for Photovoltaics Research

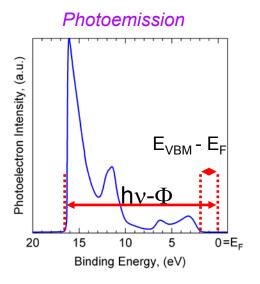
Craig L. Perkins and Xiaonan Li National Renewable Energy Laboratory, Golden, CO 80401

NREL/PR-520-43324

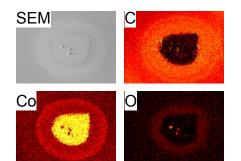
Presented at the 33rd IEEE Photovoltaic Specialist Conference held May 11-16, 2008 in San Diego, California

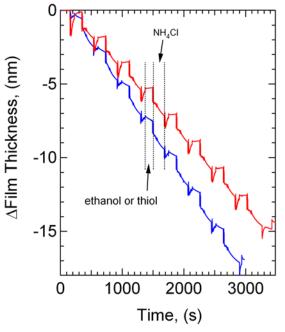
#### STF 140 cluster tool: PES/AES/MS/LQCM





AES mapping & spectroscopy

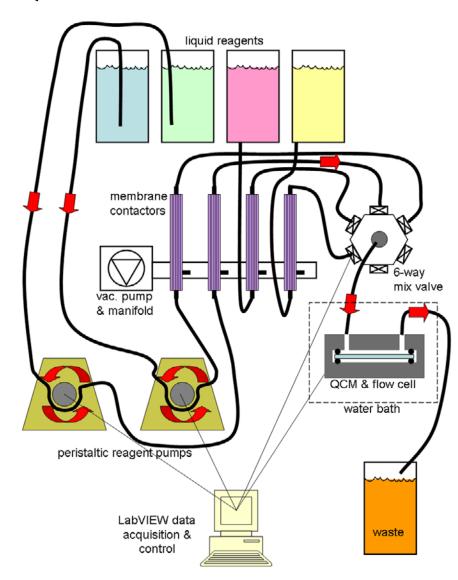




controlled ambient transfer, QCM, chemical growth, etching, & modification

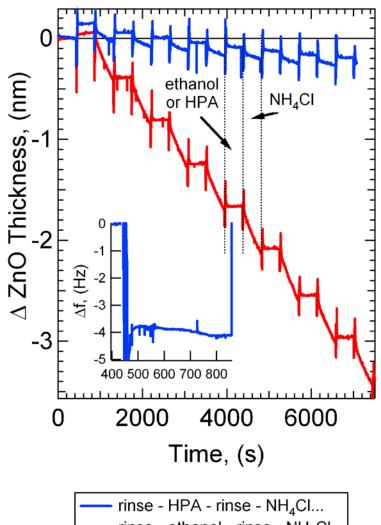
- M. Law et al. "The Structural, Optical and Electrical Properties of PbSe Nanocrystal Solids Treated Thermally and with Simple Amines", *J. Am. Chem. Soc.*,(2008) ASAP article.
- J.M. Luther et al., "The Structural, Optical, and Electrical Properties of Self-Assembled Films of PbSe Nanocrystals Treated with 1,2-ethanedithiol", *ACS Nano*, **2** (2008) 271-280.
- G. Teeter, "X-ray and ultraviolet photoelectron spectroscopy measurements of Cu-doped CdTe(111)-B: Observation of temperature-reversible CuxTe precipitation and effect on ionization potential", *J. Appl. Phys.*, **102** (2007) 034504.

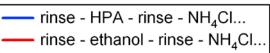
#### **QCM-Based Flow Reactor Schematic**

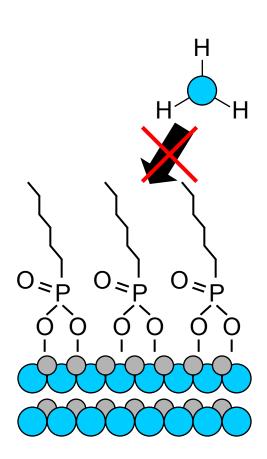


$$\Delta f = -f^{3/2} \sqrt{\frac{\eta_L \cdot \rho_L}{\pi \cdot \mu_q \cdot \rho_q}}$$

### NH₄CI: Using an Etchant as a Probe of ZnO-molecule Interactions

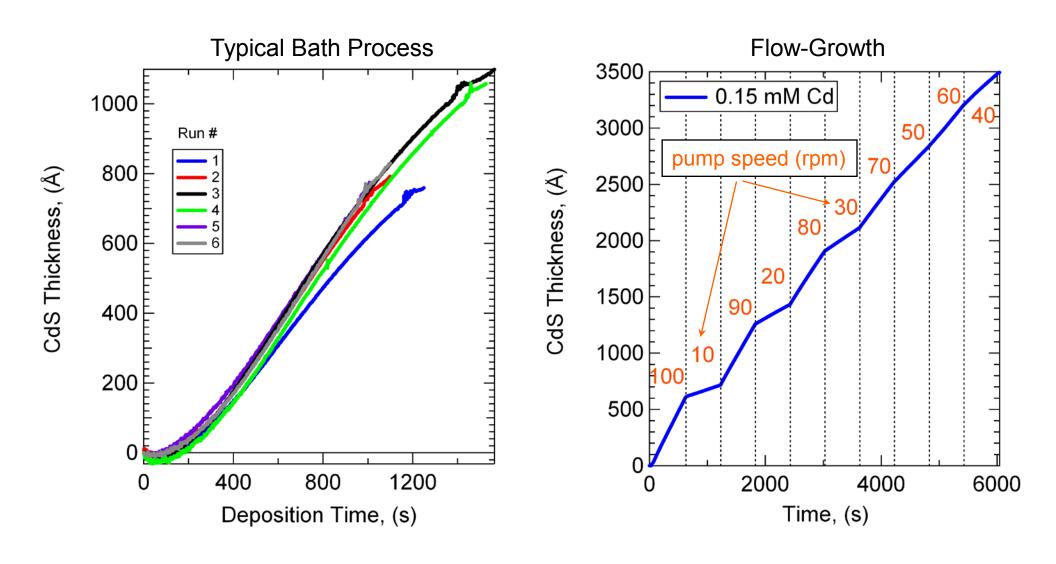




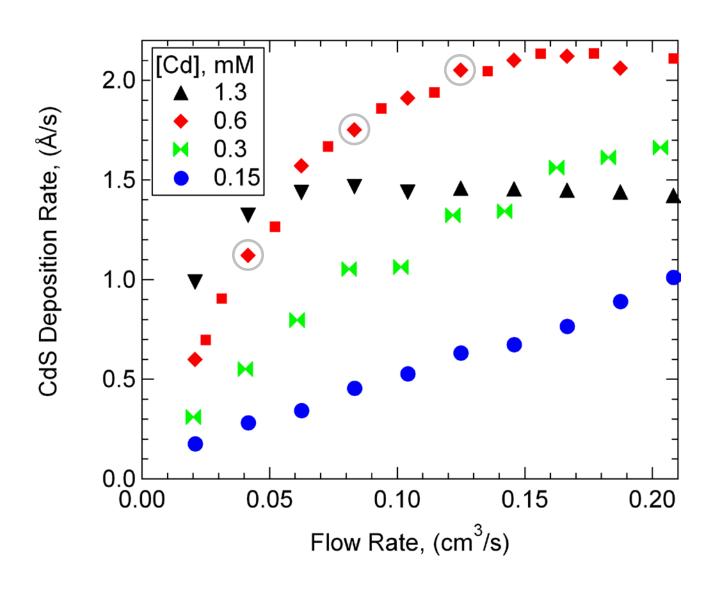


 $4 \text{ Hz} \rightarrow 2.6 \text{ x } 10^{14} \text{ mol} \cdot \text{cm}^{-2}$ or 0.24 monolayer.

### **QCM Thickness Data for CdS Chemical Depositions**

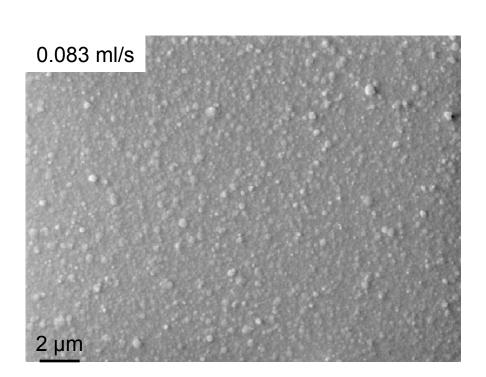


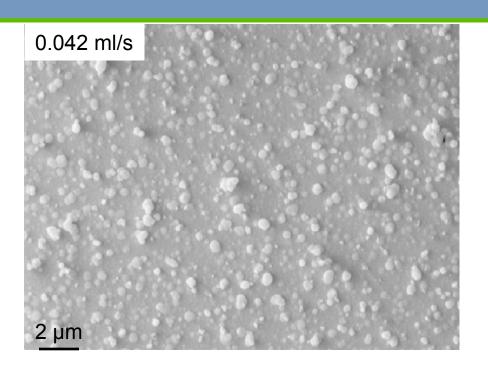
## **Deposition Rates as f(flow, [reactants])**

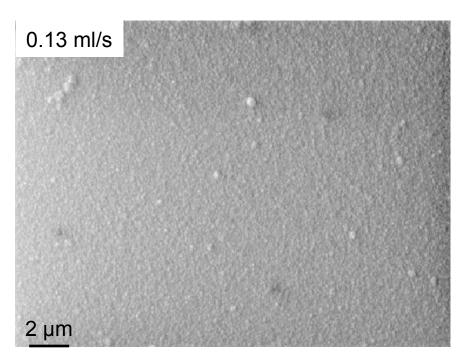


# Flow-Rate Dependent Morphology of Chemically Grown CdS Films

Film thickness = 
$$0.4 \mu m$$
  
 $T_{growth} = 63 \, {}^{\circ}C$ 







### **Summary**

- Construction of a new QCM-based flow reactor has been completed
- Initial results include:
  - Stable oscillation achieved with crystals sputter coated at 200 °C with 500 nm ZnO
  - Sub-Hz noise level means << monolayer sensitivity</p>
  - Operation at elevated temperature possible after installation of membrane contactors
  - Determination of ZnO etch rates using dilute ethanolic NH<sub>4</sub>CI
  - Demonstration of use of an etchant as a probe of oxide-molecule interactions.
  - Use in flow rate-dependent CdS chemical deposition

#### **Acknowledgments:**

Xiaonan Li, Sally Asher, Glenn Teeter, Pete Sheldon

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